

**International workshop on non-invasive beam profile monitors for hadron machines and its related techniques: 3rd IPM workshop**

Contribution ID: 16

Type: **not specified**

**Resolving profile distortion for electron-based IPMs  
using Machine Learning**

*Tuesday, 18 September 2018 10:30 (30 minutes)*

**Presenter:** Mr VILSMEIER, Dominik (GSI Helmholtz Centre for Heavy Ion Research)

**Session Classification:** IPM system